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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10069943	FILING DATE 07/10/2002	CLASS 501	SUBCLASS 98.4	GAU 1755	EXAMINER Group
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**CONTINUING DATA VERIFIED:

This application is a 371 of PCT/JP00/03041 05/12/2000

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** FOREIGN APPLICATIONS VERIFIED:

JAPAN 11-251842 06/09/1999
JAPAN 11-251843 06/09/1999
JAPAN 11-355550 12/15/1999

PG-PUB DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials	ATTORNEY DOCKET NO 219289USOPCT
TITLE: Carbon-containing aluminium nitride sintered compact and ceramic substrate for use in equipment for manufacturing or inspecting semiconductor	
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L/Rev. 12-94	

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
ISSUE FEE		Assistant Examiner	
Amount Due	Date Paid	Total Claims	Print Claims for O.G.
PRIMARY EXAMINER		DRAWING	
DISCLAIMER		Sheets Drawn	Figs. Drawn
PREPARED FOR ISSUE		Print Fig.	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.		Application Examiner	

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